

00862.022498



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	)	
TAKAO YONEHARA, ET AL.	)	Examiner: Brook Kebede
Application No.: 10/059,144	)	Group Art Unit: 2823
Filed: January 31, 2002	)	
For: METHOD OF MANUFACTURING	)	
THIN-FILM SEMICONDUCTOR	)	
DEVICE	)	March 15, 2005

**Mail Stop Amendment**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT

Sir:

In response to the Office Action dated December 15, 2004, please amend  
the above-referenced application as follows.

I hereby certify that this correspondence is being deposited with the  
United States Postal Service as first-class mail in an envelope  
addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria,  
VA 22313-1450 on

March 15, 2005  
(Date of Deposit)

Damond E. Vadnais, Reg. No. 52,310  
(Name of Attorney for Applicant)

A handwritten signature in dark ink, appearing to read "Damond E. Vadnais".

Signature

March 15, 2005

Date of Signature